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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Inventor: Michael LAMLA et al.

Application No.: 09/486,723 ✓

Confirmation No: 2431

Filed: May 18, 2000

Attorney No.: LAML3003/JEK/JJC

Customer No.: 23364

Examiner: Odaiche T. AKPATI

Art Unit: 2135

For: METHOD FOR TESTING THE AUTHENTICITY OF A DATA CARRIER

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to Rule 37 C.F.R. §1.51(b), §1.56, §1.97, and §1.98, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. Any other documents or information submitted for consideration by the Examiner are listed in this paper.

A copy of each of the references cited in the International Search Report is not provided herewith as it has been acknowledged that copies of these references are already on the file as indicated in Form PCT/DO/EO/903 mailed to the Applicants on May 30, 2000. If the file is missing copies of the cited references, the Examiner is encouraged to contact the Applicants who will furnish copies of such references.

**Additional Documents or Information Not Listed on
Accompanying Form PTO-1449 Submitted for Consideration**

International Search Report dated March 3, 1999 in corresponding PCT application PCT/EP98/05669.

Application No.: 09/486,723
Examiner: Odaiche T. AKPATI
Art Unit: 2135

Statement of Cumulative Information

DE 44 19 805 A corresponds to U.S. 5,850,524 as shown in the International Search Report.

Statement of Timeliness

This Information Disclosure Statement is submitted after three months from (i) the filing date of the above-identified U.S. National Patent application, or (ii) after three months from entry into the U.S. National Stage of the above-identified International Application, or (iii) the date of entry into the U.S. National Stage of the International Application that has been assigned the above-identified U.S. Patent application number, whichever applies; and after the mailing date of the first Office Action on the merits of the above-identified application, but prior to issuance of any Final Action, Notice of Allowance, or Action closing prosecution sent in such application.

The fee required under 37 C.F.R. § 1.97(c) and § 1.17(p) is submitted herewith.

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

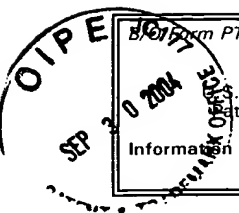
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Date: September 30, 2004

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Justin J. Cassell", written over a horizontal line.

JUSTIN J. CASSELL
Attorney for Applicants
Registration No. 46,205



B/O Form PTO-1449 U.S. Department of Commerce Patent and Trademark Office Information Disclosure Statement by Applicant	Atty. Docket Number LAML3003/JEK/JJC	Serial Number 09/486,723
	Applicant Michael LAMLA et al.	
	Filing Date May 18, 2000	Group 2135

U.S. Patent Documents

Examiner Initial	Document Number	Date	Patentee/Applicant	Class	Subclass	Filing Date if Appropriate
	4,985,921	Jan. 1991	Schwartz			

Foreign Patent Documents

Examiner Initial	Document Number	Publication Date	Country/Agency	Class	Subclass	Translation	
						Yes	No
	44 19 805 A	Dec. 1995	Germany				
	2 298 613 A	Sep. 1996	Great Britain				

Other Documents (Including Author, Title, Date, Pertinent Pages, Place of Publication, Etc.)

Examiner	Date Considered
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EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP 609; Draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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